IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Gyu-Chan JEONG et al.

Serial No. [NEW]

Filed: November 6, 2003

For: LOAD PORT OF A SEMICONDUCTOR MANUFACTURING

APPARATUS HAVING INTEGRATED KINEMATIC COUPLING PINS AND SENSORS, AND METHOD OF LOADING WAFERS USING THE

SAME

PRELIMINARY AMENDMENT

U.S. Patent and Trademark Office 2011 South Clark Place Customer Window, Mail Stop Patent Application Crystal Plaza Two, Lobby, Room 1B03 Arlington, VA 22202

Sir:

Preliminary to the examination of the above-identified application, please enter the following amendments and consider the following remarks:

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 6 of this paper.